



RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 1725  
PATENT APPLICATION

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q81941

Kenji ITO, et al.

Appn. No.: 10/500,253

Group Art Unit: 1725

Confirmation No.: 8926

Examiner: Maria A. ELVE

Filed: June 25, 2004

For: LASER MATERIAL PROCESSING METHOD

**RESPONSE UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 27, 2006, please consider the remarks as submitted herewith on the accompanying pages.